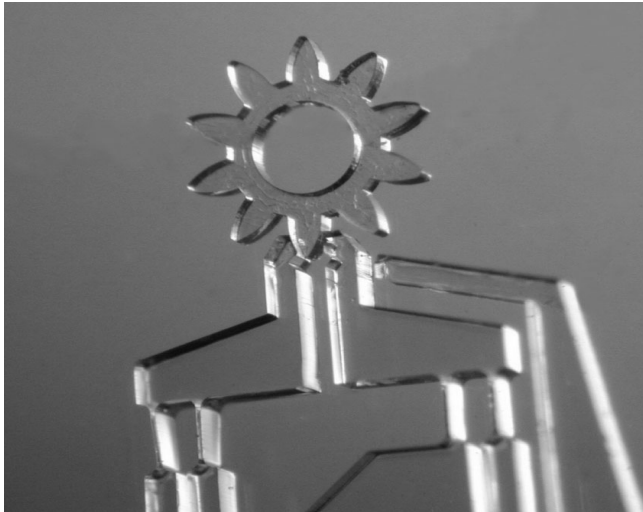


10 Years of Teaching and Research
5 Years of Clean Room Operation

REPORT

1991 - 2001



Institute for Microtechnology
Technical University of Braunschweig

Die Deutsche Bibliothek - CIP-Einheitsaufnahme

**10 Years of Teaching and Research, 5 Years of Clean Room Operation,
Report 1991-2001** / S. Büttgenbach (Editor).

Aachen : Shaker, 2002

(Berichte aus der Mikro- und Feinwerktechnik ; Bd. 7)

ISBN3-8322-0283-8

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Printed in Germany.

ISBN 3-8322-0283-8

ISSN 1433-1438

Shaker Verlag GmbH • P.O. BOX 1290 • D-52013 Aachen

Phone: 0049/2407/9596-0 • Telefax: 0049/2407/9596-9

Internet: www.shaker.de • eMail: info@shaker.de

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